

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of:	§	
Chih-Tsung Lin	§	Group Art Unit: Unknown
	§	
Serial No. Unknown	§	
	§	Examiner: Unknown
Filed: Herewith	§	
	§	
For: A Knowledge Slicing And	§	
Encapsulating Method In A Semiconductor		
Manufacturing System		

**INFORMATION DISCLOSURE STATEMENT**

Commissioner For Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In compliance with the duty of disclosure under 37 CFR §1.56, and in accordance with the practice under 37 CFR §1.97 and §1.98, the Examiner's attention is directed to the documents listed on the enclosed modified Form PTO-1449. No inference should be made that the cited references are in fact material, are in fact prior art, or that no better art exists. The cited patents are listed in numerical order and are not in any order based on their pertinence.

The above-identified application is being filed after June 30, 2003. Therefore, pursuant to the waiver of the requirement under 37 CFR 1.98 (a)(2)(i) as stated in a Pre-OG Notice dated July 11, 2003, copies of only the foreign patent documents and non-patent literature listed on the enclosed modified Form PTO-1449 are attached.

This Information Disclosure Statement is being filed within three months of the United States filing date or before the mailing date of a first Office Action on the merits. No certification or fee is required (37 CFR §1.97(b)).

The Commissioner is hereby authorized to charge any additional fees which may be required or credit any overpayment to Deposit Account 08-1394.

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Respectfully submitted,

*T. F. Bliss*

Timothy F. Bliss  
Registration No. 50,925

Date: 3/12/04  
HAYNES AND BOONE, LLP  
901 Main Street, Suite 3100  
Dallas, Texas 75202-3789  
Telephone: 972-739-8638  
Facsimile: 214-200-0853  
File: 24061.60

R-69465.1

**Certificate of Mailing**

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to Commissioner For Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on 3-12-04.

Bonnie Boyle

Printed Name

*Bonnie Boyle*  
Signature

In place of PTO-1449 Form				U. S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	
<b>INFORMATION DISCLOSURE          STATEMENT BY APPLICANT</b> <i>(use as many sheets as necessary)</i>					
SHEET      1      OF      2				<i>Complete if Known</i>	
				Application Number	Unknown
				Filing Date	Herewith
				Applicant(s)	Chih-Tsung Lin
				Art Unit	To Be Determined
				Examiner Name	To Be Determined
				Attorney/Docket Number	24061.60

[illegible][illegible]

OTHER PRIOR ART		
Examiner's Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article, title of the item, date, page(s), volume-issue number(s), publisher, city/country where published
	AE	YUSOF, NORAZAH, et al., "Domain-Expert Repository Management for Adaptive Hypermedia Learning System", IEEE International Conference on Advanced Learning Techniques, 2001, 2 pgs.
	AF	YUSOF, NORAZAH, et al., "Domain-Expert Repository Management for Adaptive Hypermedia Learning System", IEEE IEEE International Conference on Advanced Learning Techniques, 34 pgs.
	AG	HU, YU-SHU, et al., "Evaluating System Behavior Through Dynamic Master Logic Diagram (DMLD) Modeling", Elsevier Science Ltd., Reliability Engineering and System Safety 64, June 15, 1998, pp. 241-269.
	AH	KECECI, NIHAL, et al., "Analyzing, Measuring & Assessing Software Quality Within A Logic-Based Graphical Framework", Qualita, March 22-23, 2001, 8 pgs.
	AI	KECECI N. et al, "System-Software Interfaces for Safety-Related Digital I&C Systems", Center for Reliability Engineering MD USA, 6 pgs.

Examiner Signature		Date Considered	
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include a copy of this form with next communication to applicant.

In place of PTO-1449 Form		U. S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		Complete if Known	
<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> <i>(use as many sheets as necessary)</i>				Application Number	Unknown
				Filing Date	Herewith
				Applicant(s)	Chih-Tsung Lin
				Art Unit	To Be Determined
				Examiner Name	To Be Determined
SHEET	2	OF	2	Attorney Docket Number	24061.60

U. S. PATENT DOCUMENTS				
Examiner's Initials	Cite No.	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document

FOREIGN PATENT DOCUMENTS					
Examiner's Initials	Cite No.	Foreign Patent Document (Country Code - Number - Kind)	Publication Date MM-DD-YYYY	Patentee or Applicant of Cited Document	Translation Y/N

OTHER PRIOR ART		
Examiner's Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article, title of the item, date, page(s), volume- issue number(s), publisher, city/country where published.
	AJ	KECECI. NIHAL, et al. "Software Development Life Cycle Model to Ensure Software Quality", Abstract, 1 <sup>st</sup> International Workshop of Functioning Modeling of Complex Technical Systems, Ispra, Italy 1993, 7 pgs.
	AK	"Dynamic Master Logic - Unified Software", User Manual, DML-US 2000 User's Manual, 135 pgs.

Examiner Signature		Date Considered	
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